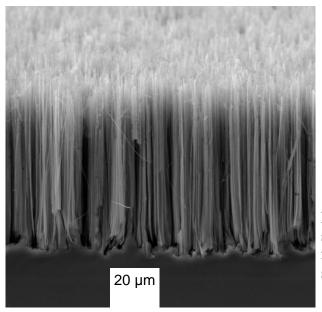
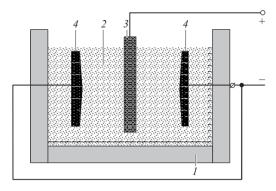
Research (What is it about?)	Pulsed formation changes the parameters of porous silicon			
UNN authors	Demidov E., Abrosimov A., Demidova N., Karzanov, V.			
We find (The	It is demonstrated that photoluminescence spectrum and			
result)	conductivity of porous silicon change if pulsed anodic mode of its			
	formation is used			
Abstract	Being one of the basic materials of modern electronics, monocrystalline			
	silicon is not a radiation material as such. However porous silicon which			
	can be prepared by electrochemical etching of monocrystalline silicon in			
	hydrofluoric acid (HF) solutions has a perceptible yield of			
	photoluminescence. Porous silicon is a three-phase system of nanoscale			
	silicon fibers and grains, coated by a silicon oxide layer and air betwee			
	them. The unwanted broad photoluminescence band in it is due to a la spread in the size of silicon grains. It is of interest to reduce this spread order to narrow the photoluminescence spectrum and to increase the quantum yield of such radiation. Up to now all attempts to achieve the			
	result concerned a stationary etching process.			
	We have studied the influence of the <i>pulsed modes</i> of formation of porous			
	silicon with the periods of 1÷8 seconds at the parameters of porous			
	silicon. We find that the biggest <i>increase in luminescence</i> , by a <i>factor of</i>			
	2.5 compared with the continuous mode, takes place at a modulation			
	period 1 s. We also find a higher conductivity of porous silicon layers			
	obtained in the pulsed mode and an increase in conductivity with			
	increasing the modulation period in a 1÷8 seconds range.			

Representative articles 2017-2018, quartiles	 Demidov E.S., Abrosimov A.S., Demidova N.E., Karzanov, V.V. Effect of the parameters of pulsed anodic formation of porous silicon on its luminescent, paramagnetic, and electrotransport properties. Physics of the Solid State. 59(2), 251-253 (2017). 		Q4
Q-index (Qi) for the result		1	
		high green	
In collaboration	_		





Electrochemical etching of silicon and a sample of porous silicon structure: 1 - fluoroplastic cup, 2 - HF electrolyte, 3 - silicon anode, 4 - platinum cathodes.

